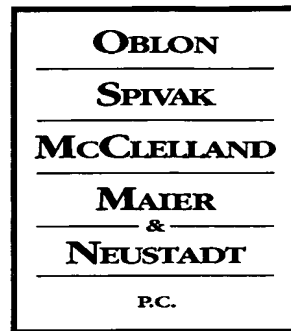




IFW

Docket No.: 239499US2

COMMISSIONER FOR PATENTS  
ALEXANDRIA, VIRGINIA 22313



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RE: Application Serial No.: 10/603,821

Applicants: Yukio TANIGUCHI, et al.

Filing Date: June 26, 2003

For: CRYSTALLIZATION APPARATUS, OPTICAL  
MEMBER FOR USE IN CRYSTALLIZATION  
APPARATUS, CRYSTALLIZATION METHOD,  
MANUFACTURING METHOD OF THIN FILM  
TRANSISTOR, AND MANUFACTURING METHOD  
OF MATRIX CIRCUIT SUBSTRATE OF DISPLAY

Group Art Unit: 2812

Examiner: ISAAC, S. D.

SIR:

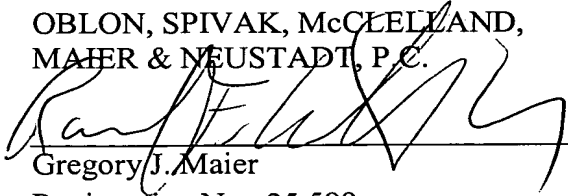
Attached hereto for filing are the following papers:

#### RESTRICTION REQUIREMENT

Our check in the amount of -0- is attached covering any required fees. In the event any variance exists between the amount enclosed and the Patent Office charges for filing the above-noted documents, including any fees required under 37 C.F.R. 1.136 for any necessary Extension of Time to make the filing of the attached documents timely, please charge or credit the difference to our Deposit Account No. 15-0030. Further, if these papers are not considered timely filed, then a petition is hereby made under 37 C.F.R. 1.136 for the necessary extension of time. A duplicate copy of this sheet is enclosed.

Respectfully submitted,

OBLON, SPIVAK, McCLELLAND,  
MAIER & NEUSTADT, P.C.



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DOCKET NO: 239499US2



IN THE UNITED STATES PATENT & TRADEMARK OFFICE

IN RE APPLICATION OF :  
YUKIO TANIGUCHI, ET AL. : EXAMINER: ISAAC S. D.  
SERIAL NO: 10/603,821 :  
FILED: JUNE 26, 2003 : GROUP ART UNIT: 2812  
FOR: CRYSTALLIZATION APPARATUS, :  
OPTICAL MEMBER FOR USE IN  
CRYSTALLIZATION APPARATUS,  
CRYSTALLIZATION METHOD,  
MANUFACTURING METHOD OF THIN  
FILM TRANSISTOR, AND  
MANUFACTURING METHOD OF  
MATRIX CIRCUIT SUBSTRATE OF  
DISPLAY

RESTRICTION REQUIREMENT

COMMISSIONER FOR PATENTS  
ALEXANDRIA, VIRGINIA 22313

SIR:

In response to the Restriction Requirement dated November 22, 2004, Applicants provisionally elect with traverse Group I, Claims 1-15 and 26-28 directed to an apparatus for examination on the merits in the present application. Applicants make this election based on the understanding that Applicants are not prejudiced against filing one or more divisional applications that cover the non-elected claims.

Applicants traverse because, according to MPEP § 803:

If the search and examination of an entire application can be made without serious burden, the Examiner must examine it on the merits, even though it includes claims to distinct or independent inventions.

Although the Office Action has identified separate classifications, making a *prima face* case of a serious burden, it is respectfully submitted that there is no serious burden in searching and examining the entire application.

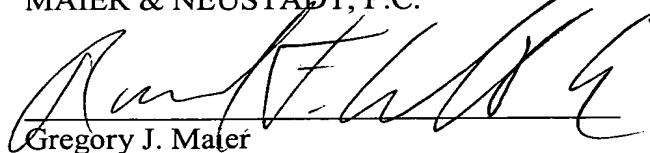
As patents and other publications in this art often contain descriptions of both a process and the apparatus implementing the process, information as to both process and apparatus can be found in the same publication. It is thus very likely that patents and publications in the field of the claimed process will have descriptions of the apparatus in which the process is implemented, greatly facilitating the prior art search and the consideration of both apparatus and process claims.

Accordingly, Applicants respectfully traverse the Restriction Requirement on the grounds that a search and examination of the entire application would not place a *serious* burden on the Examiner, whereas it would be a serious burden on Applicants to prosecute and maintain separate applications on the restricted inventions.

Therefore, it is respectfully requested that the requirement to elect a single group be withdrawn, and that a full examination on the merits of Claims 1-36 be conducted.

Respectfully submitted,

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